



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG833628785
Report verification at iqi.org

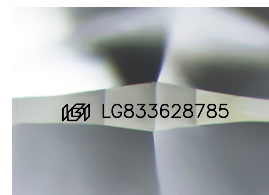
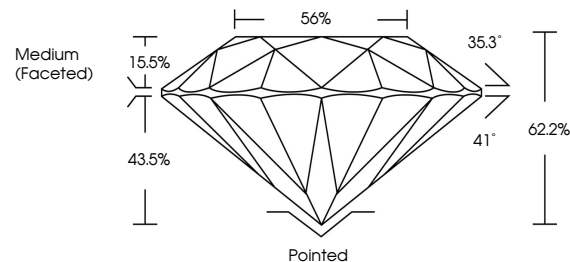
September 4, 2026	
IGI Report Number	LG833628785
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.30 - 9.33 X 5.80 MM
GRADING RESULTS	
Carat Weight	3.09 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG833628785

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

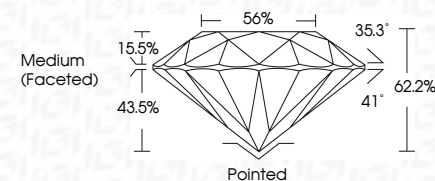
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

September 4, 2026
ICI Report No LG833628785
ROUND BRILLIANT

9.30 - 9.33 X 5.80 MM	Carat Weight	3.09 CARATS
	Color Grade	E
	Clarity Grade	VVS 2
	Cut Grade	IDP AL
	Depth	62.2%
	Table	56%
	Grade	Medium (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions	see inscriptions

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.